



AP
IPW

PATENT
81839.0142

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Eiichi IINO, et al.

Serial No: 10/695,609

Filed: October 28, 2003

For: SILICON SEED CRYSTAL AND METHOD
FOR PRODUCING SILICON SINGLE
CRYSTAL

Art Unit: 1722

Examiner: Matthew J. Song

I hereby certify that this correspondence
is being deposited with the United States
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Commissioner for Patents
P.O. Box 1450
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October 5, 2006

Date of Deposit

John P. Scherlach, Reg. No. 23,009

Name

Signature 10/05/06

Signature

Date

**NOTICE OF APPEAL FROM THE PRIMARY
EXAMINER TO THE BOARD OF APPEALS**

Mail Stop Appeal Brief-Patents
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants hereby appeal to the Board of Appeals from the decision dated April 19, 2006 of the Primary Examiner finally rejecting claims 10-13. The item(s) checked below are appropriate:

1. ☒ A third one-month extension of time to respond to the final rejection is hereby requested under 37 C.F.R. § 1.136 and is enclosed with the proper fee.
2. ☒ A timely response to the final rejection has been filed, as provided in 841 O.G. 1411.
3. The application is on behalf of
☒ other than a small entity.

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☒ Fee ☐ \$250 ☒ \$500

☒ enclosed.

☐ not required (fee paid in prior appeal).

☒ charged to Deposit Account No. 50-1314 if any additional fees are required.

(An additional copy of this Notice is enclosed.)

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: October 5, 2006

By: 

John P. Scherlacher

Registration No. 23,009

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